



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasunaga KAYAMA

Group Art Unit: 2851

Application No.: 09/713,215

Examiner: P. Kim

Filed: November 16, 2000

Docket No.: 107314

For: EXPOSURE APPARATUS AND METHOD THAT EXPOSES A PATTERN ONTO A
SUBSTRATE (AS AMENDED)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 27, 2003 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

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